

U.S. Department of Commerce, Patent and Trademark Office						Atty Docket No.		Serial No.	
						M-7511 US		09/825,225	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant(s)			
(Use several sheets if necessary)						Larry D. Barto, et al			
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EF	AQ	"Agent Enhanced Manufacturing System Initiative," Technologies for the Integration of Manufacturing Applications (TIMA) (October 1997), NIST Advanced Technology Program <a href="http://jazz.nist.gov/atpcf/pjbriefs/pjbrief.cfm?ProjectNumber=97-05-0018">http://jazz.nist.gov/atpcf/pjbriefs/pjbrief.cfm?ProjectNumber=97-05-0018</a> , September 6, 1999							
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EF	AS	Axtell, Robert and Joshua Epstein, "Distributed Computation of Economic Equilibria via Bilateral Exchange," <i>Brookings Institution and Santa Fe Institute</i> , March 1997.							
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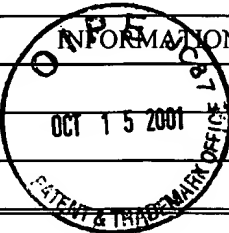
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